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Assistant Commissioner of Patents
Box PATENT APPLICATION
Patent and Trademark Office
Washington, D.C. 20231

RE: Patent Application filed herewith:

Inventorship: **MARTIN RICHARDSON**
Title: **EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA
PRODUCED FROM LIQUID METAL SOLUTIONS**
Docket: **UCF-287**

Honorable Commissioner:

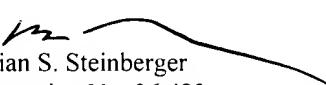
Enclosed is an original U.S. Patent Application, including 6 sheets of Informal Drawings (in duplicate), a Declaration/Power of Attorney, Assignment, Recordation Cover Sheet, 17 U.S. Patent Copies, 2 foreign patent copy, 5 publication copies, Information Disclosure Statement, Form PTO-1449 and Prior Art Statement, and Nonpublication Request.

The fee is calculated as follows. Two checks payable to the Commissioner of Patents and Trademarks in the total amount of \$593.00 is enclosed.

FEE CALCULATION

| | |
|--|-----------------|
| Basic Filing Fee | \$355.00 |
| Independent Claims in excess of 3: <u>2</u> - 3 = <u>1</u> @ \$40.00 = | \$000.00 |
| Total Claims in excess of 20: <u>42</u> - 20 = <u>22</u> @ \$9.00 = | \$198.00 |
| Total Filing Fee: | \$553.00 |
| <i>Recordation and Assignment:</i> | 40.00 |
| TOTAL FEE: | \$593.00 |

Respectfully submitted,


Brian S. Steinberger
Registration No. 36,423

I certify that this correspondence, including the attachments listed, is being deposited with the United States Postal Service, Express Mail Post Office to Addressee service, receipt No. EL742064669US, in an envelope addressed to Assistant Commissioner of Patents, Washington, D.C. 20231, on the date shown below.

6/14/01

Date of Mailing

Signature of Person Mailing



United States Patent Application for

EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA PRODUCED FROM LIQUID METAL SOLUTIONS

Inventors: **MARTIN RICHARDSON**

for the University of Central Florida

Attorney's Docket No. UCF-287

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